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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/531,391	04/15/2005	Masashi Watanabe	070759-0033	6874
20277 MCDERMOTT	7590 08/09/2007 Γ WILL & EMERY LLP		EXAMINER	
600 13TH STREET, N.W.			NIU, XINNING	
WASHINGTON, DC 20005-3096			ART UNIT	PAPER NUMBER
			2828	
			MAIL DATE	DELIVERY MODE
		•	08/09/2007	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)			
Office Action Summary	10/531,391	WATANABE ET AL.			
Office Action Summary	Examiner	Art Unit			
	Xinning(Tom) Niu	2828			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period was reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).			
Status		•			
1) Responsive to communication(s) filed on <u>01 June 2007</u> .					
, 					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is				
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims		•			
4) ☐ Claim(s) 1-5 and 9 is/are pending in the application 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-5 and 9 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/o	wn from consideration.				
Application Papers					
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomposed and all accomposed are all accomposed and accomposed accomposed are all accomposed accomposed are all accomposed accomposed and accomposed accomposed are all accomposed accomposed accomposed accomposed accomposed and accomposed accompos	epted or b) objected to by the drawing(s) be held in abeyance. Setion is required if the drawing(s) is ob	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
•		•			
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:	ate			

DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claim 1-5, 9 rejected under 35 U.S.C. 103(a) as being unpatentable over De Poorter (U.S. Patent 5,578,863) in view of Onomura et al. (2002/0039374).
- 3. Regarding Claim 1, De Poorter discloses:
 - Semiconductor laser device (10) comprising a semiconductor laser
 element (3) inside an airtight sealed package (20) (Figure 1).
 - Atmospheric gas inside the package contains oxygen (Col 4, Lines 21-23).

De Poorter does not disclose:

 Semiconductor laser device having active region formed of a gallium nitride based crystal.

However, Onomura et al. disclose:

InGaN quantum well laser (claim 15).

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It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the laser apparatus as taught by De Poorter by mounting the InGaN laser device on the laser package in order to emit optical radiation at a lower wavelength.

- 4. Regarding Claim 2, De Poorter discloses:
 - Semiconductor laser element having a dielectric oxide film (4) formed on a laser emission surface (Figure 1; Col 3, Lines 59-62).
- 5. Regarding Claim 3, De Poorter discloses:
 - Atmospheric gas inside the package is a mixture of oxygen and nitrogen with an oxygen content of 20% or more (Col 2, Lines 23-44).

De Poorter does not disclose:

Output of semiconductor laser device is 30mW or more.

However, Onomura et al. disclose:

- Output of semiconductor laser device is 30mW or more ([0058]).
- 6. Regarding Claim 4, De Poorter as modified discloses:
 - Semiconductor laser emitting light having a wavelength of 0.9 μm or less (Onomura et al. ([0058]).
- 7. Regarding Claim 5, De Poorter discloses:

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 Atmospheric gas inside the package is a mixture of oxygen and nitrogen with an oxygen content of 20% or more (dry air) (Col 2, Lines 23-44).

De Poorter does not disclose:

• Output of semiconductor laser device is 30mW or more.

However, Onomura et al. disclose:

- Output of semiconductor laser device is 30mW or more ([0058]).
- 8. Regarding claim 9, please see the rejection for claim 1.

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Aikiyo discloses a method for hermetically sealing a semiconductor laser device using oxygen.

9. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the

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shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Response to Arguments

10. Applicant's arguments with respect to claims 1-5, 9 have been considered but are moot in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Xinning(Tom) Niu whose telephone number is 571-270-1437. The examiner can normally be reached on M-T, 7:30-5:00 EST, Alternate Fridays 7:30-4:00 ES.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Min Sun Harvey can be reached on (571) 272-1835. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Xinning Niu 08/02/2007

